

Notice of References Cited	Application/Control No. 10/037,447	Applicant(s)/Patent Under Reexamination EGAN ET AL.	
	Examiner Cybille Delacroix-Muirheid	Art Unit 1614	Page 1 of 1


U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	HCAPLUS DN:124:31230, Takahashi et al., JP 07196712 (1995-08-01), 9 pages, (abstract only).
	V	HCAPLUS DN:94:103319, Federsel et al., Tetrahedron Letters, 21(25), (1980), pages 2429-32, (abstract only).
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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